

IFW



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q79367

Kazuya UENISHI, et al.

Appln. No.: 10/756,753

Group Art Unit: 2881

Confirmation No.: 1538

Examiner: Bernard E. SOUW

Filed: January 14, 2004

For: THIN FILM ANALYZING METHOD

**RESPONSE UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 14, 2005, please consider the remarks as submitted herewith on the accompanying pages.

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